



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAHIRO OHMI, ET AL.

Application No.: 09/494,945

Filed: February 1, 2000

For: LASER OSCILLATING APPARATUS,
EXPOSURE APPARATUS USING
THE SAME, AND DEVICE
FABRICATION METHOD

Examiner: D. Florez Ruiz
Group Art Unit: 2828

December 8, 2003

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TECHNOLOGY CENTER 2800

THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In response to the Official Action mailed September 8, 2003, the Examiner
is respectfully requested to consider and enter the following amendments.